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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Athavale et al.

Examiner: Deo, Duy Vu Nguyen

Serial No: 09/757,123

Group Art Unit: 1765

Filed: January 9, 2001

Docket: 01 P7408 US 02 (8055-142)

For: **METHOD FOR DRY ETCHING DEEP TRENCHES IN A SUBSTRATE**

Mail Stop: Fee Amendment
Commissioner for Patents
P.O. Box 1450
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AMENDMENT

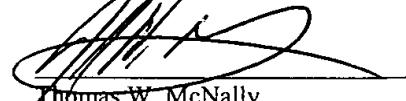
This is a response to the Office Action mailed on September 29, 2003. Please consider the following amendments and remarks to the above-identified application as follows:

02/06/2004 HDAMTE1 00000073 500679 09757123
02 FC:1201 10.00 DA 162.00 OP

CERTIFICATE OF MAILING 37 C.F.R. § 1.8(a)

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Dated: 29 January 2004



Thomas W. McNally